

Subst. Form PTO-1449 APPLICANT(S)' INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: FLCZ 2 00364 (H-4136)	Serial No.: 10/082,461
Applicant(s): Szymanski, et al.		RECEIVED JUN 24 2003 TC-100
Filing Date: February 25, 2002		Group: Unknown

U.S. PATENT DOCUMENTS							
Initial*		Document No.	Date	Name	Class	Subcl.	Filing Date
UV	AA	5,929,259	07/1999	Lockemeyer	—	—	
UV	AB	5,057,481	10/1991	Bhasin	—	—	
UV	AC	5,384,302	01/1995	Gerdes, et al.	—	—	
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						

FOREIGN PATENT DOCUMENTS							
		Document No.	Date	Country	Class	Subcl.	Translation
UV	AP	EP 0 327 356	02/1989	Europe	—	—	
UV	AQ	EP 0 496 386	01/1992	Europe	—	—	
UV	AR	WO 97/46317	06/1997	PCT	—	—	
	AS						
	AT						
	AU						

OTHER ART							
	AV 1						
	AV 2						

Examiner: UVUVUV Date Considered: UVUVUV

\* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if in conformance and not considered. Include copy of this form with next communication to applicant.

**FORM 6-1**

Section 2. Form PTO - 1449 (Modified)

FORM PTO-1449  
INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT



ATTY. DOCKET NO.  
H-4136

SERIAL NO.  
10/082,761

APPLICANT Szymanski et al

FILING DATE  
February 25, 2002

GROUP

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE If appropriate
UV	2,069,060	Jan. 1937	Fessler	—	—	
UV	4,812,437	Mar. 1989	Nojiri et al	—	—	
UV	4,822,900	Apr. 1989	Hayden	—	—	
UV	4,939,114	Jul. 1990	Nojiri et al	—	—	
UV	5,100,859	Mar. 1992	Gerdes et al	—	—	
UV	5,145,824	Sep. 1992	Buffum et al	—	—	
UV	5,187,140	Feb. 1993	Thorsteinson et al	—	—	

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

	DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
UV	EP 003642	Aug. 1979	EPO	—	—		
UV	EP 076504	Apr. 1983	EPO	—	—		
UV	EP 266015	May 1988	EPO	—	—		
UV	EP 927575	Jul. 1999	EPO	—	—		
UV	WO 00/15333	Mar. 2000	WO	—	—		
UV	WO 00/15334	Mar. 2000	WO	—	—		
UV	WO 00/15335	Mar. 2000	WO	—	—		
UV	JP 11240777	Sep. 1999	JP	—	—	abstract only	
UV	JP 2000044331	Feb. 2000	JP	—	—	x	

OTHER DOCUMENTS (Including Author, Title, Date\*\*, Relevant Pages, Place of Publication\*\*\*)

UV	Encycl. of Chemical Technology (Kirk-Othmer) Vol. 5, pp 610-633; Vol. 9, pp 445-471.	considered
UV	Treatise on Materials Science and Technology Edited by Franklin Wang; Vol. 9, pp 79-81.	not checked
UV	Introduction to the Principles of Ceramic Processing, (Reed) pp 152-182. © 1988	not worth

EXAMINER

*UV*

DATE CONSIDERED

*11/17/03*

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**FORM 6-1**

6-17

Section 2. Form PTO - 1449 (Modified)

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO. H-4136	SERIAL NO. 10/082,761
APPLICANT Szymanski et al		
FILING DATE February 25, 2002		GROUP

**U. S. PATENT DOCUMENTS**

**FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION**

**OTHER DOCUMENTS (Including Author, Title, Date\*\*, Relevant Pages, Place of Publication\*\*\*)**

11. *What is the name of the author of the book you are reading?*

**EXAMINER**

**DATE CONSIDERED**

IV1703

**Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.**